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Workshop on Plasma Physics | (smr 1523)

Tuesday 11 November 2003

Development of Materials Processing Methods: Cathodic Vacuum Arc and Plasma Immersion Ion Implantation Combined - Main Building Main Lecture Hall (14:00-15:00)

time	title	presenter
14:00	Development of Materials Processing Methods: Cathodic Vacuum Arc and Plasma Immersion Ion Implantation Combined	M. BILEK